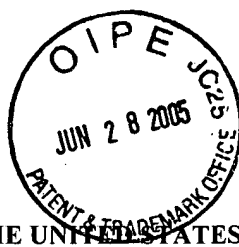


Docket No.: 063979-0027



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Gaku SUGAHARA, et al. : Confirmation Number: 3885
Application No.: 10/611,851 : Group Art Unit: 2828
Filed: July 03, 2003 : Examiner: JACKSON, Cornelius H.

For: NITRIDE SEMICONDUCTOR LASER DEVICE AND FABRICATING METHOD THEREOF

Mail Stop Amendment Transmittal
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.
☒ Applicant is entitled to small entity status under 37 CFR 1.27
☒ Also attached: Certified copy translation of the Japanese Priority Document (JP 2002-11337)

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	7	20	0	\$50.00 =	\$0.00
Independent Claims	2	3	0	\$200.00 =	\$0.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$0.00

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Fogarty
Registration No. 36,139

**Please recognize our Customer No. 20277 as our
correspondence address.**

600 13th Street, N.W.
Washington, DC 20005-3096
Phone: 202.756.8000 MEF:dmd
Facsimile: 202.756.8087
Date: June 28, 2005

Docket No.: 063979-0027



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Gaku SUGAHARA, et al.	:	Confirmation Number: 3885
Application No.: 10/611,851	:	Group Art Unit: 2828
Filed: July 03, 2003	:	Examiner: JACKSON, Cornelius H.
For: NITRIDE SEMICONDUCTOR LASER DEVICE AND FABRICATING METHOD THEREOF		

AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop Amendment
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 28, 2005, having a three-month shortened statutory period for response set to expire June 28, 2005, please amend the above-identified application as follows: